

Disco DFG 841

Specifications		DFG841		
Wafer Diameter		MAX \varnothing 200 (\varnothing 4"~8")	(mm)	
Grinding Method		In-feed grinding with wafer rotation		
Spindle	Type used	Air bearing with a highfrequency motor		
	No. of spindles	2		
	Output	4.2	(kW)	
	Spindle speed	1000~7000	(Each spindle independently adjustable, with a real-time display of both rpm and spindle speed)	min^{-1} [rpm]
		Vertical stroke		
	Vertical in-feed speed range	0.00001~0.08		(mm/s)
	Vertical rapid feed speed	50		(mm/s)
	Minimum step for vertical movement	0.1		(μm)
	Minimum resolution for vertical movement	0.1		(μm)
	Height Gauge	Measurable range	0~1000	(μm)
Resolution		0.1	(μm)	
Accuracy		± 0.5	(μm)	
Wafer Chuck Table	Table type	Porous chuck table		
	Chucking method	Vacuum		
	Revolution Speed	0~300(Can be set in 1 rpm Increments)	min^{-1} [rpm]	
	No. of tables	2		
	Chuck table cleaning	backflushing of water and compressed air is combined with oilstone cleaning		
	Spark-out revolution control	0~999 revolutions		
Grinding Wheel		\varnothing 200(\varnothing 8")diamond wheel	(mm)	
Wafer Loading/Unloading	Cassette storage quantity Cassette flow Spinner unit	Two cassettes Same flow(return to original slot) Wafer washing and drying on both sides		
Non-Recirculating Grinding/Wafer Supply System And Vacuum Pump System(standard accessory)	Water flow rate	15	(ℓ/min)	
	Water pressure	0.3[3.0]	(MPa·G[kgf/cm^2 ·	
	Air discharge rate	560/660 ℓ/min	50/60Hz (-74kpa)	(l/min)
		Air pressure		
	Electric motor	Grinding water:0.75		(kW)
	Water flow rate	Vacuum pump:1.5		(kW)
	(For water temperature greater than	5		(ℓ/min)
(For water temperature greater less	5		(ℓ/min)	
Grinding Accuracy(\varnothing 8" wafer)	Planarity accuracy (within wafer)	0.0015 (when a dedicated chuck table is used)	(mm)	
	Thickness accuracy (wafer to wafer)	± 0.003	(mm)	
	Finish surface roughness	around Ry 0.13 (at #2000finish) around Ry 0.15 (at #1400finish)	(μm)	
Others	Power source	3-phase 200V		
		AC $\pm 10\%$ or less 50/60Hz		
	Power consumption	17	(kVA)	
	Grounding resistance	100 Ω or less		
	Electrical noise	2,000 V or less with a pulse width of 500 ns(square wave)		
	Air pressure	0.5~0.8[5.0~8.0]	(MPa·G[kgf/cm^2 ·	
	Air flow rate	300	(N ℓ/min)	
	Water pressure	0.2~0.3[2~3]for cooling water	0.2~0.3[2~3]for grinding waetr	(MPa·G[kgf/cm^2 ·G])
		Water flow rate		
	Exhaust duct capacity	4 (at the duct connection port on the main unit)	(m^3/min)	
	Machine dimensions	1,050W*2,150D*1,710H	(mm)	
Machine weight	2,300	(kg)		